Title: "System And Method For Cleaning Semiconductor Fabrication Equipment Parts: Inventor: S. TAN Serial No.: 09/927,263
Attorney Docket No. 59081-8005.US01 (1 of 9 Sheets)

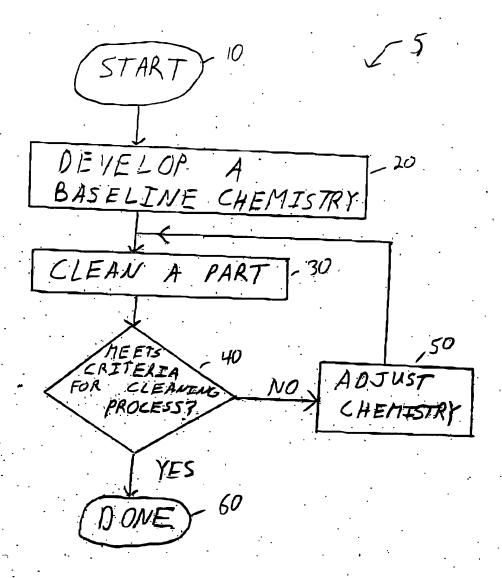
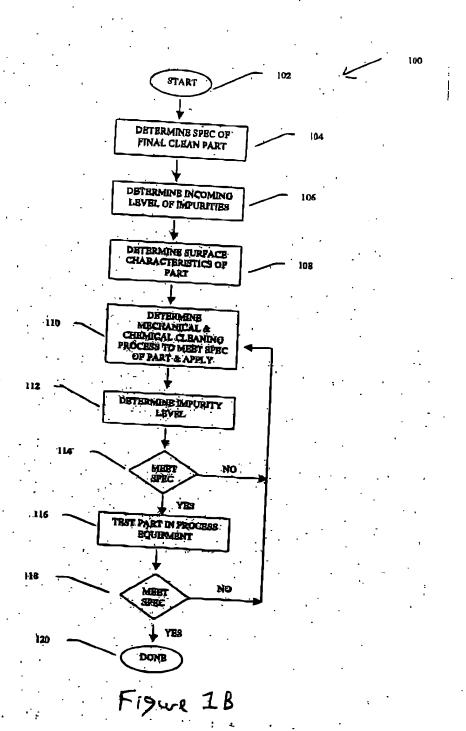


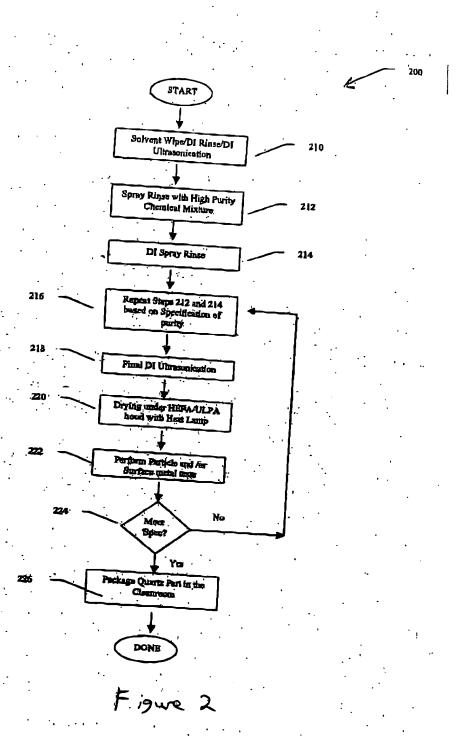
FIGURE 1A

<u>Title:</u> "System And Method For Cleaning Semiconductor Fabrication Equipment Parts:
Inventor: S. TAN Serial No.: 09/927,263
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<u>Title</u>: "System And Method For Cleaning Semiconductor Fabrication Equipment Parts:

Inventor: S. TAN Serial No.: 09/927,263
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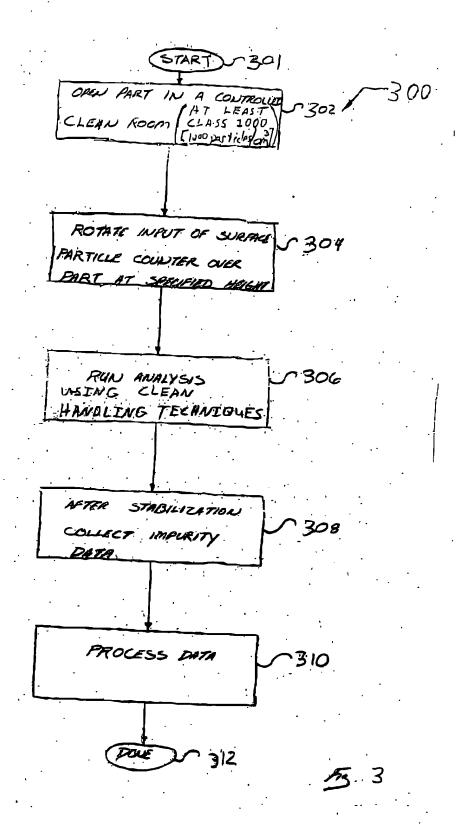


Title: "System And Method For Cleaning Semiconductor

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Inventor: S. TAN Serial No.: 09/927,263

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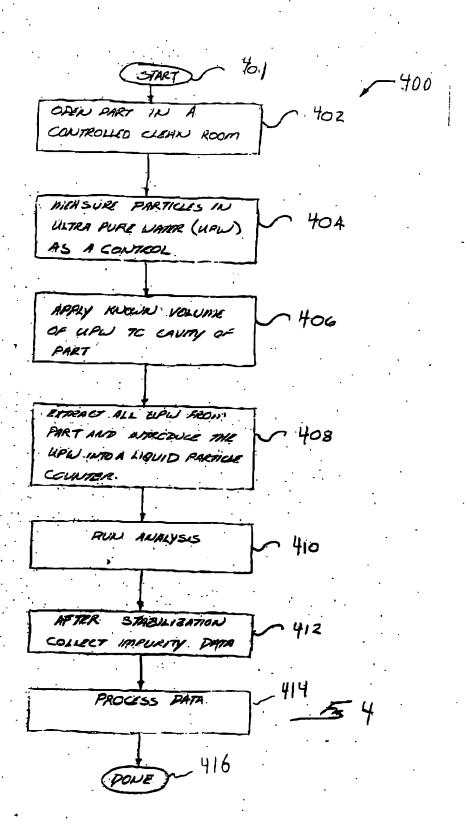


Title: "System And Method For Cleaning Semiconductor

Fabrication Equipment Parts:

Inventor: S. TAN Scrist No.: 09/927,263

Attorney Docket No. 59081-8005,US01 (5 of 9 Sheets)

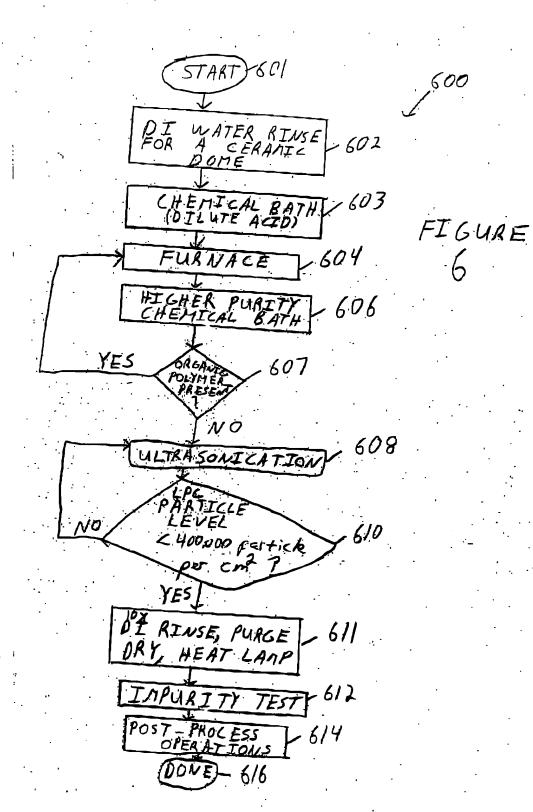


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START OPEN PART IN CONTROLLEO EN VIRONMENT PREPARE HIGH PURITY EXTRACTION
SOLUTION EXTRACTION SCLUTION TO EXTRACT AND TEST SOLUTION FOR METALLIC IMPURITIES PROCES SINC

FIGURE 5

Title: "System And Method For Cleaning Semiconductor Fabrication Equipment Parts: Inventor: S. TAN Serial No.: 09/927,263
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Inventor: S. TAN Serial No.: 09/927,263

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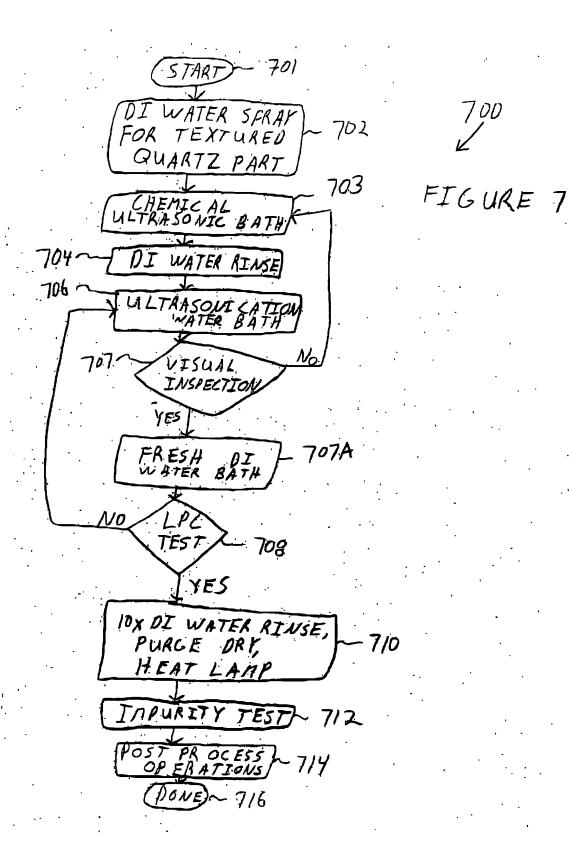


FIGURE 8

<u>Title</u>: "System And Method For Cleaning Sciniconductor Fabrication Equipment Parts:

Inventor: S. TAN Serial No.: 09/927,263
Attorney Docket No. 59081-8005,US01 (9 of 9 Sheets)

